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J. Beckers and G. M. W. Kroesen

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Surprising temperature dependence of the dust particle growth rate in low pressure Ar/C$_2$H$_2$ plasmas

J. Beckers$^{a}$ and G. M. W. Kroesen
Eindhoven University of Technology, Department of Applied Physics, P.O. Box 513, 5600 MB Eindhoven, The Netherlands

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We have experimentally monitored the growth rate of dust particles in a low pressure Ar/C$_2$H$_2$ radiofrequency discharge as a function of the gas temperature $T_g$ and independent of the C$_2$H radical density and the gas density. Used diagnostics are laser light scattering and measurements of the phase angle between the RF voltage and current. In contrast to most literature, we demonstrate that the growth rate is not a monotonically decreasing function of $T_g$ but shows a maximum around $T_g = 65^\circ$C. In addition, we demonstrate that the phase angle is an accurate measure to monitor the particle growth rate. © 2011 American Institute of Physics. [doi:10.1063/1.3658730]

The possible appearance of dust particles is recognized to be of major importance for almost every application in which chemically reactive plasmas are utilized, e.g., for manufacturing of solar cells, semiconductors, and nanostructures. Also in astrophysics, dusty plasmas play an important role. More recently, the problem of dust particles in nuclear fusion devices, influencing plasma operation, demands for more understanding of the processes that dominate the creation and growth of these particles. An important parameter herein is the gas temperature $T_g$. Although hydrocarbon plasma chemistry and dust particle formation has been investigated by several researchers, experimental data on $T_g$ dependencies are scarce. The few experiments reporting on the $T_g$ dependent particle growth rate $R_p$ in silane and methane all demonstrate decreasing particle growth rates at elevated $T_g$'s.$^{5,6}$

The experiments are performed in a grounded cylindrical stainless steel vacuum vessel (diameter: 300 mm and height: 500 mm), discussed in Ref. 3. The aluminum lid closing this vessel is heated and the gas is supplied towards the showerhead RF powered top electrode (diameter: 138 mm)—ensuring a homogeneous gas flow—through a narrow channel (diameter: 1 mm and length: 80 mm) in the lid material. Since this large length/diameter ratio (80), the supplied gas is safely assumed to have the same temperature as the vessel lid (roughly 13 collisions between gas particles and the lid material). The RF electrode is insulated by a Teflon ring from the grounded setup parts. A grounded cylindrical aluminum plasma chamber (diameter: 140 mm and height: 40 mm) is mounted, electrically and thermally conducting, below the vessel head. The bottom of this chamber consists of an aluminum grid through which the gas can escape without friction. The sidewalls and the bottom have the same temperature as the vessel lid (verified by measurements). Hence, no thermophoretic effects are present. Opposite to each other, the sidewall contains two vertically aligned slits (5 mm in width) through which a vertical sheet of 532 nm laser light is directed radially through the discharge. The pressure $p$ was kept constant at typically 0.3-0.9 mbar. As discharge gas a mixture (8.2 sccm) of 6% C$_2$H$_2$ in argon was used. For all measurements, the typical RF (13.56 MHz) plasma power was 5 W. The phase angle between the RF voltage and current $\phi_{RF}$ was monitored with 100 ms time resolution by a commercially available radio frequency plasma impedance monitor (PIM) of Scientific Systems. The scattered laser light was collected from below through the bottom grid, after which its intensity $I_s$ was measured with 100 ms time resolution with an Ocean Optics HR2000+ spectrometer.

Formation and growth of dust particles can be described by the four-stage (I-IV) formation mechanism, originally developed for silane discharges; first, negative ions are formed (I) growing due to polymerization chemistry into primary clusters (II). These clusters nucleate into particles of a few nanometers. Once these nanoparticles reach a critical density, they rapidly coagulate (III) to ultimately form permanently negatively charged particles, typically 20-50 nm in size. After coagulation, the particle size increases linearly by deposition of plasma species on their surface (stage IV) while their density $n_p$ remains constant, i.e., the negatively charged particles are confined within the positive plasma potential and no new particles are created since reactive species are rather deposited on the particle’s surface than creating new particles. When the particles become too large, the confining electric force is not able to overcome the non-confining ones anymore, the particles are lost from the discharge and $n_p$ starts to decrease. This stage we refer to as stage (V). Figure 1 shows typical measurements of $\phi_{RF}$ and $I_s^{1/6}$ for the first 15 s after plasma ignition, demonstrating that it is possible to distinguish between the stages (I), (IV), and (V). Within stage (IV), $\phi_{RF}$ increases linearly in good approximation as the growing dust particles extract an increasing amount of free electrons from the discharge, increasing the plasma resistance. The reason for plotting $I_s^{1/6}$ in Fig. 1 becomes clear when realizing that $I_s$ scales with $n_p^{1/6}$. Since in stage (IV) $n_p$ is constant, $I_s \propto n_p^{1/6}$ and, consequently, $r_p \propto I_s^{1/6}$. Although no absolute particle sizes can be derived from $I_s^{1/6}(t)$, it does provide an accurate measure for the particle size and the growth rate $R_p$ in relative terms. We define $R_p,LLS$ from the slope of the curve in phase (IV) as

$^{a}$Author to whom correspondence should be addressed. Electronic mail: j.beckers@tue.nl.
As can be observed in Fig. 1, \( R_{p,LLS} \) is constant in phase (IV). This is in perfect agreement with constant particle growth rates in comparable Ar/C\(_2\)H\(_2\) RF plasmas determined ex-situ by means of SEM by Berndt et al.\(^4\) Consequently, this is a verification that, indeed, \( n_p \) is constant. In Fig. 2, we have plotted the normalized values of \( R_{p,LLS} \) at \( T_g = 25 \) °C as a function of \( p \) and compared the results with simultaneously measured values of \( R_{p,\phi RF} \). 

\[
R_{p,LLS} = \frac{\Delta R_p}{\Delta t} \propto \frac{\Delta (l_p^{1/6})}{\Delta t}.
\]  

(1)

Also, the obtained values of \( R_{p,\phi RF} \) at the corresponding temperature and pressure combination.

In Fig. 2, for each value of \( T_g \) a pressure \( p_{pl} \) exists (see indicated for \( T_g = 150 \) °C) below which \( R_p \) increases with \( p \) and above which \( R_p \) becomes independent of \( p \) (a plateau is observed). The height of this plateau shows a maximum as a function of \( T_g \) (see Fig. 3). For \( p < p_{pl} \), at higher pressures the increasing precursor density results into a higher dissociation rate, creating more C\(_2\)H radicals per unit of time. Since it was shown that densities of positive ions are lower than the density of radicals by a factor of 1000,\(^5\) and the sticking factor for ions (roughly 1) is close to that of C\(_2\)H radicals (0.92 ± 0.05 (Ref. 9)), we assume that dust particles grow due to deposition of mainly C\(_2\)H radicals onto their surface. Increasing \( p \) thus leads directly to increasing \( R_p \). At constant mass flows, increasing \( p \) also leads to an increased residence time \( \tau_{res} \) of the gas in the plasma volume and apparently, at \( p = p_{pl} \), \( \tau_{res} \) is sufficiently long for all injected C\(_2\)H molecules to be dissociated before leaving the plasma volume. For \( p > p_{pl} \), the amount of C\(_2\)H radicals created per unit of time is independent of \( p \) and limited by the constant C\(_2\)H inflow. Hence, \( R_p \) remains constant. An estimate of the typical dissociation time \( \tau_{dis} \) given by \((n_p k_{EID})^{-1}\) with the electron density \( n_e \) typical 10\(^{15}\) m\(^{-3}\) (Ref. 10) and \( k_{EID} \) the electron impact dissociation rate \((6 \times 10^{-16} \text{ m}^3/\text{s} \text{(Ref. 4)}) \), gives \( \tau_{dis} = 1.7 \) s. Indeed, this is in the same order as \( \tau_{res} = 2.1 \) s (at 25 °C and \( p = p_{pl} = 0.47 \) mbar). Also, the obtained values of \( p_{pl} \) scale with \( T_g \) according to the ideal gas law, enhancing the conclusion that \( \tau_{dis} = \tau_{res} \) at \( p = p_{pl} \). Performing measurements at \( p_{pl} \) for each temperature consequently allows to study \( R_p \) as a function of \( T_g \) independent on gas density (constant) and radical density (100% dissociation of the partial C\(_2\)H gas density). Where most experiments and computer simulations reported in literature claim monotonically decreasing growth rates at elevated temperatures, we observe that the growth rate has a maximum around 65 °C. Giving an explanation for the observed maximum without a sophisticated model is rather difficult. However, it might be clear that more temperature dependent effects compete. For instance, at the left-hand side of the maximum, the increase in radical velocity and radical flux towards the particle with increasing temperature likely dominates. At the right-hand side, two effects might play a role. First, the value of \( n_p \) might change with temperature. However, the critical density and radius of dust particles before coagulation do not vary with temperature.\(^11\) Second, the residence time of radicals on the particle’s surface decreases with gas/particle temperature\(^9\) radicals finding an open bond to strongly chemisorb with becomes less probable, fewer radicals chemisorb and \( R_p \) is decreased.
In conclusion, we have experimentally obtained the growth rate of dust particles in Ar/C$_2$H$_2$ RF discharges as a function of pressure and temperature. The results show a maximum in the particle growth rate around 65°C. To the best of our knowledge, this has never been observed before.